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9/25/02

Docket No. 740819-430

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Shinji NAKAMURA et al.

Application Serial No. 09/680,054

Filed: October 5, 2000

For: SEMICONDUCTOR DEVICE,

SEMICONDUCTOR SUBSTRATE AND

MANUFACTURE METHOD

) Group Art Unit: 2823

) Examiner: Brook Kebede

) CERTIFICATE OF MAILING

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Jeanne Saxton

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AMENDMENT

Honorable Commissioner of Patents  
Washington, D.C. 20231

Dear Sir:

In response to the Examiner's non-final Office Action mailed April 30, 2002, the shortened statutory period for response having been extended one (1) month until August 30, 2002, please consider the following amendments and remarks in connection with the above-identified application.